

GAU 2881
#

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In application of

Yutaka KIMURA

Appln. No. 09/161,981

Group Art Unit: 2881

Confirmation No.: Unknown

Examiner: J. Davie

Filed: September 29, 1998

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND
METHOD FOR DEPOSITING SEMICONDUCTOR LAYER

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of
three month(s), extending the time for responding to the Office Action of March 28, 2001 to
September 28, 2001.

A check for the statutory fee of \$890.00 is attached. Please charge any additional fees
under 37 C.F.R. § 1.16 or § 1.17 necessary to keep this application pending in the Patent and
Trademark Office or credit any overpayment to Deposit Account No. 19-4880. A duplicate copy
of this sheet is enclosed.

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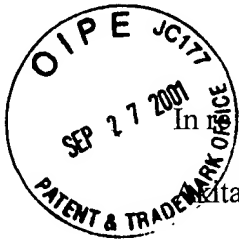
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Respectfully submitted,

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Date: September 27, 2001



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